



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 24, 2025	
IGI Report Number	LG685587756
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	10.26 X 7.04 X 4.74 MM

GRADING RESULTS

Carat Weight	3.03 CARATS
Color Grade	D
Clarity Grade	VS 1

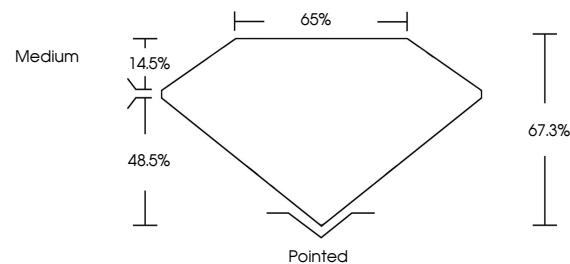
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG685587756

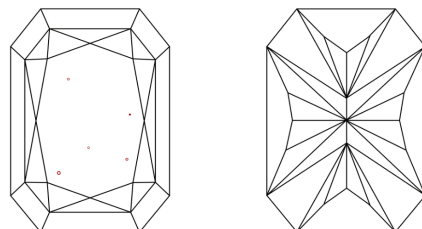
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG685587756
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

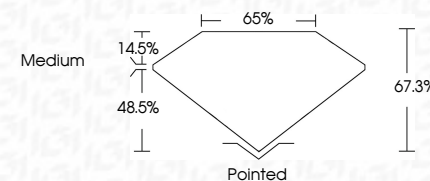
CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

January 24, 2025	3.03 CARATS
IG Report No. LG45859765	D
CU CORNERED RECT. MODIFIED BRILLIANT	VS 1
	67.5%
	65%
	Medium
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	681 LG45859765

Comments: Very Fine Crown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa